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GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

November 26, 2025

IGI Report Number **LG707511505**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **FREEFORM FACETED**

Measurements **8.00 X 5.69 X 2.61 MM**

GRADING RESULTS

Carat Weight **1.08 CARAT**

Color Grade **D**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG707511505**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG707511505
Report verification at igi.org

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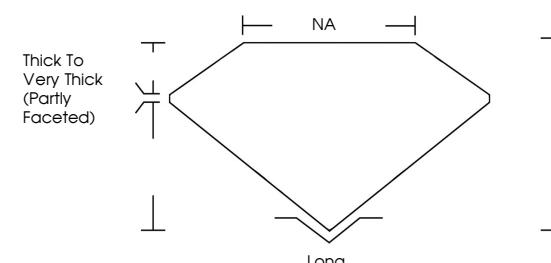
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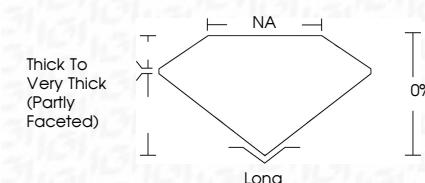
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PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	SI ¹⁻²	SI ¹⁻³	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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FREEFORM FACETED

8.00 X 5.69 X 2.61 MM

1.08 CARAT

D

VS 1

0%

NA

Thick To Very Thick (Partly Faceted)

Long

EXCELLENT

EXCELLENT

NONE

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IGI